



Docket No.: SON-2612/DIV
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shigeru Fujita

Application No.: 10/785,005

Confirmation No.: 9742

Filed: February 25, 2004

Art Unit: 2814

For: SEMICONDUCTOR DEVICE AND ITS
MANUFACTURING METHOD

Examiner: T. X. Le

AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the final Office Action dated May 13, 2005 (Paper No./Mail Date 050305), finally rejecting claims 1-5 and 13-16, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.

Please
DO NOT
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